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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yuji Horie, et al.
Serial No.: 10/666,987
Filed: September 19, 2003
For: POLISHING CLOTH AND
METHOD OF PRODUCING
SAME
Group Art Unit: 3724
Examiner: T. V. Eley
Attorney Docket: NMCI P045

CERTIFICATE OF MAILING

Date of Deposit: July 26, 2005

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RESPONSE TO REQUIREMENT FOR RESTRICTION

Commissioner for Patents
Alexandria, Virginia 22313-1450

Sir:

In response to the Requirement for Restriction dated March 21, 2005 in the above-referenced application as between Group I, consisting of claims 1-7 and Group II consisting of claims 8 and 9, applicant hereby elects Group I consisting of claims 1-7 to be examined first. The election is without traverse and does not affect the inventorship.

It now goes without saying that applicant reserves the right to file a divisional application regarding Group II currently not elected.

Respectfully submitted,


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July 26, 2005
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